

**Notice of References Cited**

Application/Control No.

10/572,855

Applicant(s)/Patent Under

Reexamination

SHIMADA ET AL.

Examiner

JOHN K. KIM

Art Unit

2834

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**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2007/0108169	05-2007	Shimada et al.	219/121.85
*	B US-2003/0201685	10-2003	Shimada et al.	310/156.53
*	C US-6,236,016	05-2001	Dulaney et al.	219/121.85
*	D US-6,848,495	02-2005	Edwards et al.	164/109
*	E US-2003/0024915	02-2003	Clauer et al.	219/121.85
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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